

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

04995/023

Application Number

#3

Applicant(s)

Kunio SAWAI

Filing Date

August 23, 2001

Group Art Unit

2652

046 U.S. PTD
09/938172
08/23/01

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
Chen	A1	9-204718	08/05/97	Japan	—	—		✓
	A2	4-310663	11/02/92	Japan	—	—		✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Chen F. Lin

DATE CONSIDERED

05/02/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.